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** CONTINUING DATA *****
 NONE *DN*

** FOREIGN APPLICATIONS *****
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| Foreign Priority claimed 35 USC 119 (a-d) conditions met | <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <i>Allowance</i> <input type="checkbox"/> no <i>Met after</i> | STATE OR COUNTRY JAPAN | SHEETS DRAWING 6 | TOTAL CLAIMS 13 | INDEPENDENT CLAIMS 4 |
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Verified and Acknowledged
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TITLE
 LSI device etching method and apparatus thereof

☐ All Fees